

AUG 27 2002

PATENT & TRADEMARK OFFICE

PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date August 27, 2002

In re the Application of

Saburo KAMIYA

Group Art Unit: 2877

Application No.: 09 661,433

Examiner: S. Turner

Filed: September 13, 2000

Docket No.: 107312

For: EXPOSURE APPARATUS AND DEVICE PRODUCTION METHOD IN WHICH POSITION OF
REFERENCE PLATE PROVIDED ON SUBSTRATE STAGE IS MEASURED (As Amended)

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

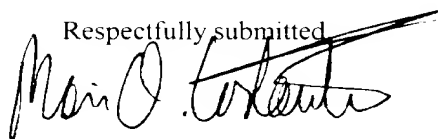
Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired June 27, 2002, an extension of time for a period of two months is hereby requested. Attached hereto is our Check No. 133860 in the amount of \$400.00 in payment for:

_____ Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
 X Extension fee for response within second month pursuant to §1.136(a) (\$400.00)
_____ Extension fee for response within third month pursuant to §1.136(a) (\$920.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted



Mario A. Costantino
Registration No. 33,565

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MAC/ccs

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
AUTHORIZATION

Please grant any extension
necessary for entry;

Charge any fee due to our
Deposit Account No. 15-0461